

Notice of References Cited	Application/Control No. 10/811,584	Applicant(s)/Patent Under Reexamination LIN ET AL.	
	Examiner Charles Chow	Art Unit 2618	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0005869	01-2004	See et al.	455/102
*	B	US-6,242,965	06-2001	Pickering et al.	327/359
*	C	US-6,359,486	03-2002	Chen, Dao-Long	327/231
*	D	US-2005/0175132	08-2005	Yang, Tony	375/350
*	E	US-6,512,408	01-2003	Lee et al.	327/359
*	F	US-5,808,498	09-1998	Donnelly et al.	327/255
*	G	US-3,296,517	01-1967	ROUTH CLAUDE C; et. al.	327/231
*	H	US-6,359,523	03-2002	Kuwano, Akira	332/103
*	I	US-2003/0016762	01-2003	Martin et al.	375/308
*	J	US-2005/0032486	02-2005	Malone et al.	455/118
*	K	US-5,574,755	11-1996	Persico, Charles J.	375/295
*	L	US-6,373,345	04-2002	Kimppa et al.	332/105
*	M	US-6,417,712	07-2002	Beards et al.	327/248

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.